

**Change Of Attorney Or Agent's Address In Application  
(37 CFR 1.8(a))**

Docket No.  
**3521.181**

In Re Application Of: **SOMIT TALWAR, ET AL.**

Serial No.  
**10/674,106**

Filing Date  
**September 29, 2003**

Examiner

Group Art Unit  
**2813**

Invention: **LASER THERMAL ANNEALING OF LIGHTLY DOPED SILICON SUBSTRATES**

**TO THE COMMISSIONER FOR PATENTS**

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Dated: **March 26, 2004**

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